



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Justin K. Brask et al.

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Art Unit: 2811

Serial No.: 10/622,955

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Examiner: Sara W. Crane

Filed: July 18, 2003

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For: Etching Metal Silicides
and Germanides

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Atty Docket: ITL.1021US
P16708

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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the restriction requirement mailed October 6, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: October 14, 2004
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
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